

September 15, 2010

VIA ECF

Honorable William D. Wall
United States Magistrate Judge
United States District Court
824 Federal Plaza
Central Islip, New York 11722

Re: Plasma Physics Corp. et al. v. Chi Mei Optoelectronics Corp. et al.,
Civil Action No. 2:08-CV-1628

Dear Judge Wall:

Plaintiffs Plasma Physics Corp. and Solar Physics Corp. (“Plaintiffs”) and Defendants Chi Mei Optoelectronics Corp. and Chi Mei Optoelectronics U.S.A., Inc. (“Defendants”) write jointly regarding the schedule in the above-referenced action.

The parties have met and conferred to discuss the pretrial schedule in view of the new November 15 trial date, and have come to agreement subject to the Court’s approval. The parties respectfully request that the Court adopt the schedule as proposed below:

Event	Proposed Deadline
Last day to file letter requests regarding dispositive motions	October 8, 2010
Plaintiffs provide draft pretrial order (listing fact and expert witnesses) and jury instructions to Defendants, along with draft Statement of Stipulated Facts	October 13, 2010
Parties exchange deposition designations	October 25, 2010
Defendants provide revised redline of draft pretrial order and jury instructions, along with redline Statement of Stipulated Facts to Plaintiffs	October 27, 2010
Motions <i>in limine</i> due	October 28, 2010
Parties exchange deposition counterdesignations	November 1, 2010
Oppositions to motions <i>in limine</i> due	November 4, 2010
Parties file Joint Pretrial Order, including Joint Statement of Stipulated Facts	November 5, 2010

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Parties exchange proposed voir dire questions and meet and confer on same if necessary	November 8, 2010
Parties exchange deposition counter-counterdesignations	November 8, 2010
Parties file joint proposed voir dire questions	November 10, 2010

Respectfully submitted,

/s/ Jennifer C. Tempesta

Jennifer C. Tempesta
Attorney for Plaintiffs

/s/ Gregory Gulia

Gregory Gulia
Attorney for Defendants